

Electronic Supplementary Information

for

**Facile formation of CoN₄ active sites onto SiO₂
support to achieve robust CO₂ and protons reduction
in a noble-metal-free photocatalytic system**

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1. Chemicals

Tetraethylorthosilicate (TEOS), γ -aminopropyltrimethoxysilane (APTMS), triethylamine, ammonium hydroxide ($\text{NH}_3 \cdot \text{H}_2\text{O}$, 25%-28%), triethylamine (TEA) and cobalt chloride hexahydrate ($\text{CoCl}_2 \cdot 6\text{H}_2\text{O}$) were purchased from commercial suppliers (Sinopharm chemical reagent co., LTD, Adamas and Sigma-Aldrich) and used without further purification. CO_2 (99.999%), CO (99.999%), CH_4 (99.99%) were purchased from commercial supplier (Huaerwen). $^{13}\text{CO}_2$ (99% ^{13}C atom) were purchased from Aldrich. All solvents of analytical grade were purchased from commercial suppliers and used without further purification. **g-C₃N₄**: g-C₃N₄ were synthesized according to previously reported procedures by heating approximately 5 g of melamine at a rate of 5 K min⁻¹ to 823 K and then maintaining this temperature for another 2 h.

2. X-Ray diffraction pattern of $g\text{-C}_3\text{N}_4$

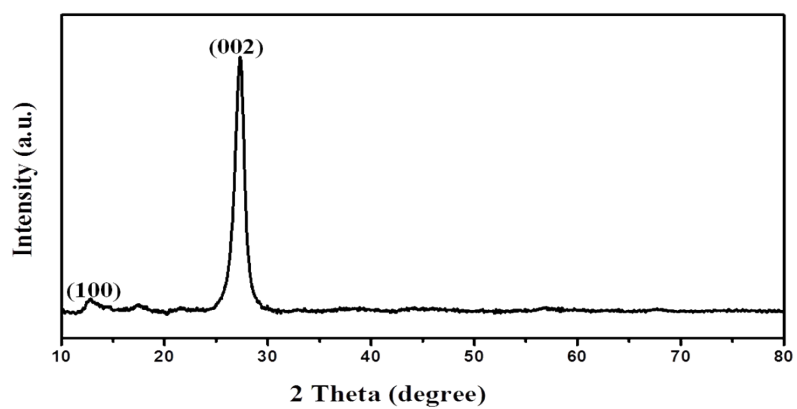


Figure S1. X-Ray diffraction spectrum of $g\text{-C}_3\text{N}_4$.

3. UV-vis diffuse reflectance spectrum of $g\text{-C}_3\text{N}_4$

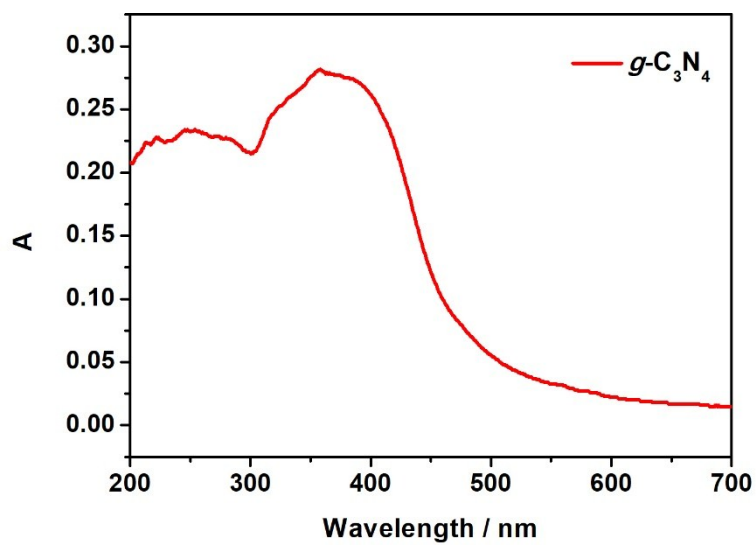


Figure S2. UV-vis diffuse reflectance spectrum of $g\text{-C}_3\text{N}_4$

4. UV-vis diffuse reflectance spectra of raw SiO_2 , $\text{NH}_2\text{-SiO}_2$ and $\text{CoN}_4\text{-SiO}_2$

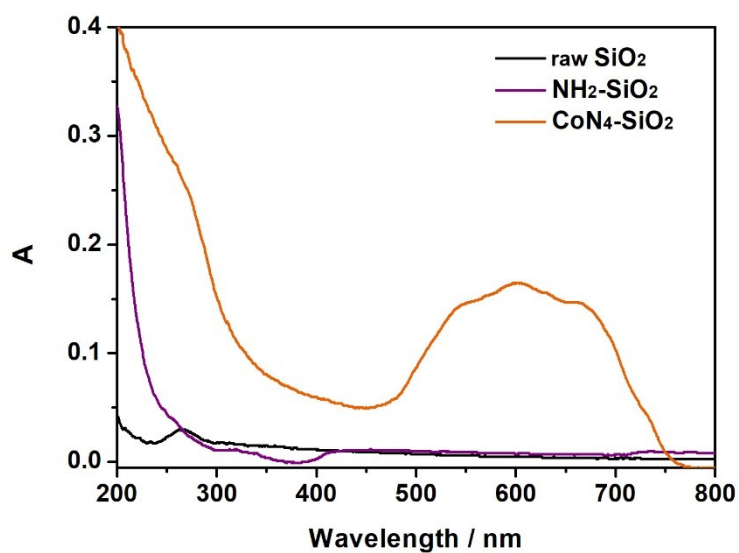


Figure S3. UV-vis diffuse reflectance spectra (DRS) of raw SiO_2 , $\text{NH}_2\text{-SiO}_2$, and $\text{CoN}_4\text{-SiO}_2$

5. IR spectra

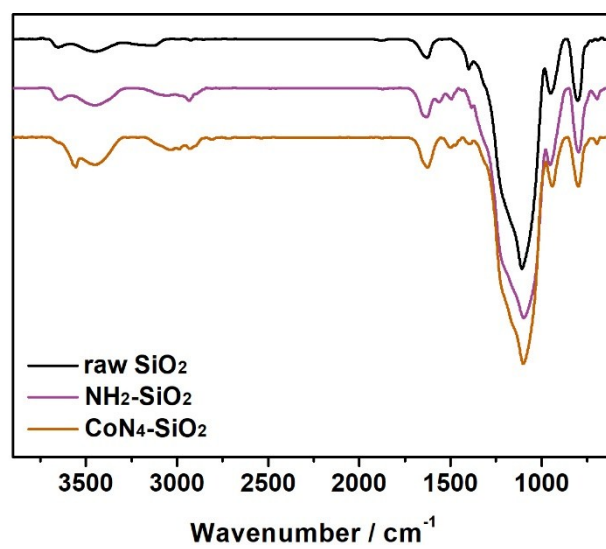


Figure S4. IR spectra of raw SiO₂, NH₂-SiO₂, and CoN₄-SiO₂

6. XPS spectra

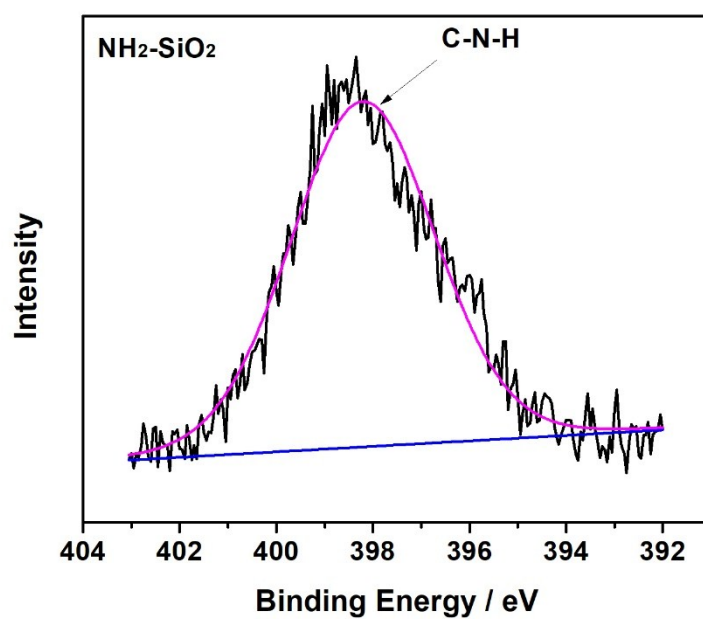


Figure S5. XPS spectrum of *N* 1s of NH₂-SiO₂

7. Photocatalytic syngas production in CH₃CN

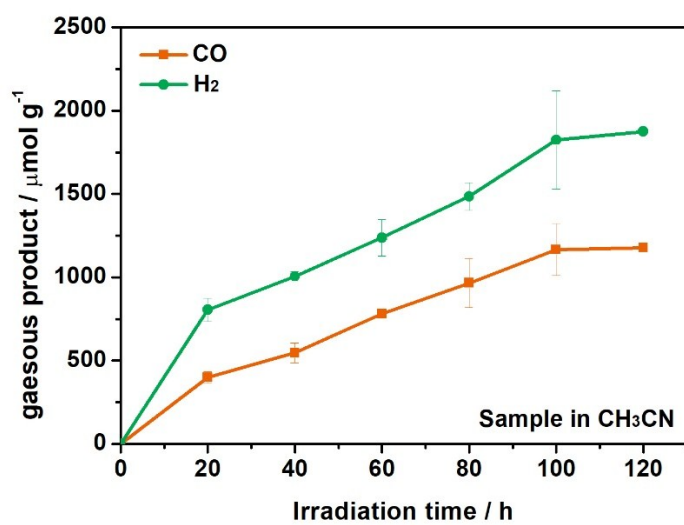


Figure S6. Long-time photocatalysis in CO₂-saturated CH₃CN; samples composition: CoN₄-SiO₂ (5.00 mg), g-C₃N₄ (10.00 mg), TEA (1.00 mL), total volume = 5.00 mL. The sample was irradiated under visible light (Blue LED, λ_{max} = 450 nm).

8. Emission spectra of $g\text{-C}_3\text{N}_4$ in the presence of TEA

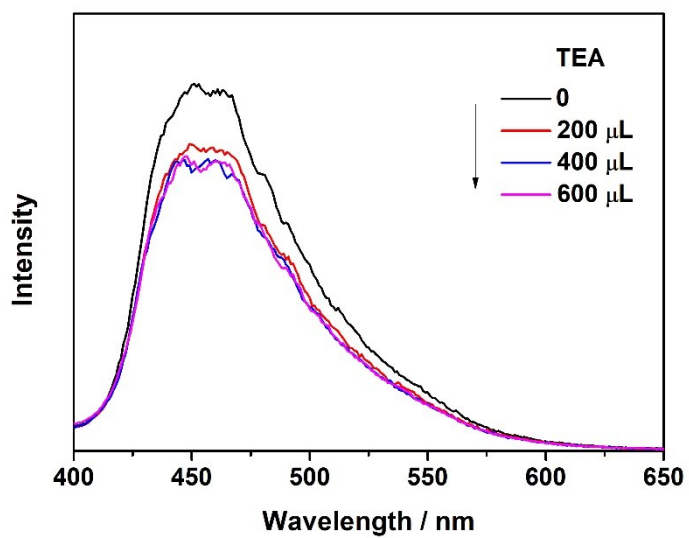


Figure S7. Emission spectra of $g\text{-C}_3\text{N}_4$ in CH_3CN in the absence and presence of $\text{NH}_2\text{-SiO}_2$ (up) or TEA (bottom) (excitation wavelength = 380 nm).

9. Comparison of the reported heterogeneous photocatalytic syngas production systems

Table S1. Comparison of the reported heterogeneous photocatalytic syngas production systems

No.	Catalyst / Photocatalyst	Photosensitizer	$n(\text{CO})$ [μmol]	$n(\text{H}_2)$ [μmol]	CO/H_2 ratio	n/m (CO) [$\mu\text{mol}\cdot\text{g}^{-1}$]	n/m (H_2) [$\mu\text{mol}\cdot\text{g}^{-1}$]	<i>Lifetime</i> [h]	Ref.
1 ^[a]	CoN₄-SiO₂	<i>g</i> -C ₃ N ₄	11.34	13.93	1.0 : 1.2	2267	2786	140	This work
2 ^[b]	CoN₄-SiO₂	<i>g</i> -C ₃ N ₄	5.89	9.38	1.0 : 1.6	1178	1875	120	This work
4	ReP + CoP/Dye/TiO ₂	-	7.73	2.21	3.5 : 1.0	773	221	10	[c]
5	Rh(PD)Au@STO	-	138.45	26.03	5.3 : 1.0	1846	347	5	[d]

[a]. In CH₃CN/H₂O ($v(\text{H}_2\text{O}) = 100 \mu\text{L}$, total volume = 5.00 mL)

[b]. In CH₃CN (total volume = 5.00 mL)

[c]. J.-S. Lee, D.-I. Won, W.-J. Jung, H.-J. Son, C. Pac, S. O. Kang, *Angewandte Chemie-International Edition* **2017**, 56, 976-980.

[d]. D. Li, S. Ouyang, H. Xu, D. Lu, M. Zhao, X. Zhang, J. Ye, *Chem. Commun.* **2016**, 52, 5989-5992.